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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): HAMAMATSU, et al.
Serial No.: 10/050,776
Filed: January 18, 2002
For: APPARATUS AND METHOD FOR INSPECTING DEFECTS
Group: 2877
Examiner: M. Stafira
Conf. No.: 9567

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

November 16, 2005

Sir:

Please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the Claims

Remarks are included following the amendments